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# **Porous fiber paper and 3D patterned electrodes composed highsensitivity flexible piezoresistive sensor for physiological signal monitoring**

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The research on flexible pressure sensors has drawn widespread attention in recent years, especially in the fields of health care and intelligent robots. In practical applications, the sensitivity of sensors directly affects the precision and integrity of weak pressure signals. Here, a pressure sensor with high sensitivity and a wide measurement range composed of porous fiber paper and 3D patterned electrodes is proposed. Multi-walled carbon nanotubes with excellent conductivity were evenly sprayed on the fiber paper to form the natural spatial conducting networks, while the copper-deposited polydimethylsiloxane films with micropyramids array were used as electrodes and flexible substrates. Increased conducting paths between electrodes and fibers can be obtained when high-density micro-pyramids fall into the porous structures of the fiber paper under external pressure, thereby promoting the pressure sensor to show an ultra-high sensitivity of 17.65 kPa<sup>-1</sup> in the pressure range of 0–2 kPa, 16 times that of the device without patterned electrodes. Besides, the sensor retains a high sensitivity of 2.06 kPa<sup>-1</sup> in an ultra-wide measurement range of 150 kPa. Moreover, the sensor can detect various physiological signals, including pulse and voice, while attached to the human skin. This work provides a novel strategy to significantly improve the sensitivity and measurement range of flexible pressure sensors, as well as demonstrates attractive applications in physiological signal monitoring.

**flexible pressure sensor, high sensitivity, wide measurement range, fiber paper, 3D patterned electrodes, physiological signal monitoring**

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# **1 Introduction**

With the rapid development of flexible electronic technology, flexible pressure sensors have demonstrated attractive applications in the field of intelligent healthcare  $[1-3]$  $[1-3]$ . Monitoring of physiological signals closely related to human health, including pulse and heart rates, has drawn growing attention among researchers and is also regarded as an important index for the performance evaluation of pressure sensors [\[4\].](#page-8-2) For the undistorted detection of these weak and diverse signals, both high sensitivity and wide linear regions are required. Highly sensitive flexible pressure sensors based on the piezoresistive effect [[5–](#page-8-3)[8\]](#page-8-4), piezoelectric effect [\[9](#page-8-5)[–12](#page-8-6)], triboelectric effect  $[13-16]$  $[13-16]$ , and capacitance effect  $[17-20]$  $[17-20]$ have been developed in recent years. Among these, piezoresistive sensors, typical sensors transducing pressure into the resistance signal, have been widely used in wearable devices for a lot of advantages, including cost-efficient fabrication, simple structure, and easy process [\[21](#page-9-3),[22\]](#page-9-4).

Numerous methods have been developed for fabricating

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flexible piezoresistive sensors with high sensing performance, such as the employment of ultra-elastic substrates, porous conducting networks, and patterned electrodes. Traditional polymer materials, including hydrogel [\[23\],](#page-9-5) polydimethylsiloxane (PDMS) [\[24\]](#page-9-6), and Ecoflex [\[25\],](#page-9-7) are considered excellent elastic substrates because of their low Young's modulus and strong chemical stability [\[26\].](#page-9-8) Elastic conducting composites with piezoresistive properties can be obtained by blending conductive materials such as metal nanoparticles [\[27\],](#page-9-9) nanowires [\[28\],](#page-9-10) graphene [\[29\]](#page-9-11), and carbon nanotubes (CNTs) [\[30\]](#page-9-12). However, due to the strong Van der Waals force, the micro-nano scale conductive particles are inclined to agglomerate in flexible substrates [\[31\],](#page-9-13) thereby resulting in inferior sensitivity and limited applications. Numerous methods have been proposed to efficiently improve the sensitivity and measurement range, such as employing porous spatial conducting framework including foam  $\left[32-34\right]$  and fiber paper  $\left[35-40\right]$  $\left[35-40\right]$  $\left[35-40\right]$ . This type of pressure sensor demonstrates enhanced sensitivity in monitoring physiological signals including pulse and voice. However, the applicative pressure range of high sensitivity is limited due to the single mechanism of resistance variation originating from the connection among conducting particles. Even though novel two-dimension multi-layer conducting materials, such as MXene [\[41](#page-9-18),[42\]](#page-9-19) can significantly enhance the range of high sensitivity by forming extra conducting paths between interlayers under larger stress [\[43](#page-9-20),[44\]](#page-9-21), the high costs of raw materials and synthetic method impede its widespread applications. Thus, the development of more effective methods to improve the sensitivity and measurement range remains an attractive project for researchers. To date, few reports have focused on the contact behavior between the surface of the flexible porous conducting framework and electrodes under external pressure. In addition to the inherent conductive networks of porous materials, changes in the contact area between patterned electrodes and sensitive layers will also cause significant changes in resistance, thereby affecting the performance of piezoresistive sensors, such as sensitivity, measurement range, and re-sponse time [\[45\]](#page-9-22).

In this work, a pressure sensor with high sensitivity and ultrawide measurement range based on porous fiber paper and 3D patterned electrodes has been proposed. Multi-walled CNTs (MWCNTs) with excellent conducting properties were evenly sprayed on the surface of fiber paper to form the sensitive material, and the Cu-deposited PDMS films with 3D micro-pyramid array structure constitute the top and bottom electrode. The geometrical shapes of the micro-pyramid and CNT content significantly influence the sensing performance, which has been quantitatively studied. With 1.5% CNT content and a standard pyramid structure, the obtained pressure sensor exhibits an ultra-high sensitivity, reaching 17.65 kPa<sup> $^{-1}$ </sup> in the pressure range of 0 to 2 kPa and 2.06 kPa<sup> $-1$ </sup> in the pressure range of 2 to 150 kPa,  $\sim$ 16 times higher than that of the device without microstructure. The excellent performance is mainly ascribed to the coupled effect of the porous structure of the fiber paper and humpelectrodes: the pyramids can fall into the interior of the fiber paper under external pressure and contact more fibers, thereby facilitating the formation of conducting paths. Based on the excellent sensing performance, the pressure sensor achieves the detection of wrist pulse, voice variation, and finger motion when attached to human skin, sufficiently meeting the requirements of practicability.

## **2 Experimental section**

## **2.1 Fabrication of wafers with micro-pyramid structure**

The micropattern on the mask  $(67 \mu m \times 67 \mu m)$  was transferred to a 4-inch Si wafer with a 500 nm-thickness  $SiO<sub>2</sub>$ layer using photolithography. Then, the exposed wafer was immersed in the BOE solution at 80°C for 5 min to etch the  $SiO<sub>2</sub>$  layer. Subsequently, the Si layer was etched by immersing in the TMAH solution at 80°C for 40 min, 30 min, and 20 min to obtain the micro-pyramid arrays and different micro-frustum array structures. The information on raw materials is provided in our previous work [\[46](#page-9-23),[47\]](#page-9-24).

## **2.2 Preparation of flexible 3D-patterned electrodes**

The PDMS matrix and curing agent (Dow Corning Sylgard 184) were fully mixed at a mass ratio of 10:1 for 15 min by mechanical stirring. Next, the mixture was kept in a vacuum box for 30 min to completely remove the bubbles. Subsequently, the PDMS mixture was spin-coated onto a silicon wafer with high-density inverted micro-pyramids at 900 rpm for 20 s and solidified at 90°C for 15 min. Then, the copper was deposited on the PDMS film by magnetron sputtering instrument (DENTON VACUUM Explorer) (thickness: 200 nm, sputtering time: 6 min). Finally, PDMS films with two different sizes (1.2 cm×1.2 cm and 1.0 cm×1.0 cm) were fabricated by cutting.

## **2.3 Preparation of MWCNT/Paper film**

First, MWCNTs (0.15 g, Nanjing Xianfeng Nanotechnology Co., Ltd.) and polyvinyl pyrrolidone (PVP K30, 0.05 g, Sinopharm Chemical Reagent Co., Ltd.) were dispersed in deionized (DI) water (9.8 g) to prepare a 1.5%-concentrate MWCNT solution, followed by ultrasonic dispersion for 40 min. Then, the well-dispersed MWCNT solution was uniformly sprayed on the two sides of fiber paper (10 cm× 10 cm) by an electric sprayer. Next, the paper-based MWCNT film was placed on the drying table (LabTechEH20B) at 70°C for 5 min. Finally, samples with a size of 1 cm×1 cm were cut from the peeled PMC film.

#### **2.4 Assembling the pressure sensor**

The PDMS electrodes were placed on top and underneath the PMC film to form a sandwich structure. Then, the sensor was protected on both sides with Kapton tapes.

## **2.5 Characterization and measurement**

The morphology of the material surface was investigated by a scanning electron microscope (SEM) (HITACHI-SU8010). The Raman and X-ray diffraction (XRD) spectra of MWCNTs were obtained using a Raman spectrometer (Renishaw inVia laser at 532 nm) and X-ray diffractometer (Cu-K radiation). The constant voltage (1 V) was applied by a DC Power supply (UTP3313TFL-II). The current was measured by an electrometer (Keithley 2611B). The compression test was performed by a tensile strength tester (GOTECH-AI-3000S).

# **3 Results and discussion**

[Figure 1](#page-2-0)(a) illustrates the manufacturing process of the pressure sensor. First, MWCNT/PVP solution dispersed via ultrasonic treatment with high stability and no hierarchy after 24 h [\(Figure 1](#page-2-0)(b)) was evenly sprayed on a fiber paper by electric spraying to form a paper/MWCNT (PMC) film. Subsequently, the mixture of PDMS and the cross-linking agent was poured onto the silicon wafer with high-density pyramids; a flexible PDMS electrode with a 3D patterned structure was obtained by curing, peeling, and copper sputtering. To assemble the pressure sensor, the PMC film was placed between the top and bottom layers of the Cu-deposited micro-pyramid PDMS film and then protected by Kapton tapes. The assembled sandwich structured sensor is shown in [Figure 1\(](#page-2-0)c).

[Figure 2\(](#page-3-0)a)–(b) presents the morphologies of the 3D patterned PDMS film characterized by SEM. Uniform formation of high-density micro-pyramid array structure is observed on the surface of PDMS film. The corresponding length of the bottom sides and the total height of a single pyramid are  $\sim$  67 μm and  $\sim$  50 μm (shown in [Figure 2\(](#page-3-0)c)), respectively. As [Figure 2\(](#page-3-0)d) shows, the fiber paper (thickness: 0.3 mm) consists of spatially interlaced fibers with an average diameter of 11.42 μm (Figure S1 Supporting information), which can easily contact each other and form conducting network under external pressure. Besides, the porous structure promotes the 3D pyramids to fall into the interior of fiber paper and contact more conducting fibers. Figure  $2(e)$ –(g) depicts the SEM images of the PMC film with different scale bars, revealing that the MWCNTs are

<span id="page-2-0"></span>





<span id="page-3-0"></span>[Figure 2](#page-3-0) (Color online) Characterization analyses of the 3D patterned structure, paper, and MWCNTs. (a)–(c) SEM images of the Cu-deposited micropyramid array film. (d) SEM image of the fiber paper surface (inset: cross section). (e)–(g) SEM images of the paper/MWCNT film. (h) XRD and (i) Raman figures of the MWCNT powders.

evenly dispersed on the fiber surfaces without serious agglomeration. The average thickness  $(\sim 0.5 \mu m)$  of a CNT film is calculated by measuring the average diameter of CNTattached fibers (Figure S1). XRD and Raman spectrum analyses were performed to characterize the MWCNT composition, as displayed in Figure  $2(h)$ –(i). The sharp diffraction peak of MWCNTs at around  $26^{\circ}$  ([Figure 2\(](#page-3-0)h)) reflects high crystallinity, contributing to the high conductivity. Besides, two sharp Raman characteristic peaks at around 1339 cm<sup>-1</sup> and 1570 cm<sup>-1</sup> are observed in [Figure 2\(](#page-3-0)i), attributed to the scattering of amorphous carbon and integrity of the  $sp^2$  hybrid bond structures, respectively.

The sensing mechanism of the pressure sensor is illustrated in [Figure 3.](#page-4-0) As Figure  $3(a)$  shows, the total resistance of the pressure sensor comprises the contact resistance  $(R_C)$  between the PMC film and micro-pyramid-structured electrodes, the self-resistance of the metal electrodes  $(R_M)$ , and alterable resistance of the PMC film  $(R<sub>P</sub>)$ . The compression strain test was performed under different pressures to investigate the compressing deformation difference between the PMC and PDMS film ([Figure 3](#page-4-0)(b)). The fiber paper generated larger deformation than PDMS under arbitrarily applied pressure due to the spatial porous structure, implying that the change in  $R_{\rm P}$  will dominate the total resistance. The dynamic model can be illustrated as follows: at the initial state, the interface between the PMC film and micro-pyramids array electrodes shows a larger resistance compared with the PMC film itself. Under low pressure (Figure  $3(c)$ ), the porous interior (inset of Figure  $2(d)$ )-induced high compressibility facilitates the connection of the conducting fibers, greatly increasing the conductivity. Simultaneously, the micro-pyramids move toward the fiber paper interior through the pores and contact more conducting fibers, thereby decreasing the contact resistance. With the continuous increase in the external pressure, the fiber paper exhibits a slower linear stress-strain behavior [\(Figure 3\(](#page-4-0)b)) due to the growing elastic force originating from the compressed fibers, with a gentle  $R<sub>P</sub>$  variation. Significantly, the micro-pyramids fallen into the paper generate significant deformation (42 μm at 150 kPa, ~85% of the micro-pyramid height) and encourage more contact points between the electrodes and the paper fibers (Figure  $3(d)$ ), inducing the increase in  $R<sub>C</sub>$ . The alterable resistance of the pressure sensor can be expressed as follows:

$$
R_{\rm p} = R_{\rm p1} / / R_{\rm p2} \cdots / / R_{\rm p_n},\tag{1}
$$

$$
R_{\rm C} = R_{\rm C1} / / R_{\rm C2} \cdots / / R_{\rm Cn},\tag{2}
$$

$$
R_{\rm Ci} = \rho_{\rm C} \frac{1}{S},\tag{3}
$$

where  $\rho_c$  is the coefficient of the contact resistance, *S* is the contact area between a single micro-pyramid and the PMC film. Therefore, the total resistance  $(R<sub>T</sub>)$  of the sensor can be



<span id="page-4-0"></span>**[Figure 3](#page-4-0)** (Color online) Sensing mechanism of the pressure sensor. (a) Schematic resistance network of the pressure sensor. (b) Compression curves of the PDMS film and the fiber paper. Real-time state of the sensor under (c) low pressure and (d) high pressure.

expressed as follows:

$$
R_{\rm T} = R_{\rm M} + R_{\rm P} + R_{\rm C}.\tag{4}
$$

When a constant voltage is supplied to the sensor by a regulated DC power supply, the current *I* flows through the apex of pyramid-like microstructure to the PMC film, varying with the contact resistance. As a vital performance index, the sensitivity (*S*) of the sensor can be defined as follows:

$$
S = \frac{I - I_0}{I_0 \Delta P} = \frac{\Delta I}{I_0} \times \frac{1}{\Delta P},
$$
\n(5)

where  $I_0$  is the initial current without external pressure and Δ*P* is the pressure variation.

To study the effect of patterned structure on the sensing performance, three kinds of pyramid-like structures, named Pyramid, Frustum 1, and Frustum 2 according to the height of the truncated small pyramid, were constructed, as shown in [Figure 4\(](#page-5-0)a)–(c) and Figure S2. The stress distribution of the three kinds of structures under vertical pressure was simulated using the COMSOL software, and the corresponding sensitivity was acquired simultaneously. As shown in [Figure 4](#page-5-0)(d), the electrode with pyramid structures applies the highest stress on the fiber paper surface under a consistent pressure (0.4 kPa). Besides, the generated strain on the fiber paper increases as the micro-pyramid height decreases, which is identical to the simulated sensitivity curve, as shown in [Figure 4\(](#page-5-0)e).

To investigate the practical performance difference between sensors containing the structured and non-structured electrodes, three pressure sensors were fabricated with different pyramid-like array electrodes. [Figure 4\(](#page-5-0)g) presents the measured current curves, from which it is observed the pyramid electrode-based sensor generates the highest valve of Δ*I*/*I*. Moreover, the Δ*I*/*I* declined with the decrease in the pyramid height, verifying the stress-induced performance enhancement of the 3D pyramid structure. Significantly, the Δ*I*/*I* valve was much higher than the simulated valve, mainly ascribed to the porous structure of the fiber paper and the



<span id="page-5-0"></span>**[Figure 4](#page-5-0)** (Color online) Measurement and simulation of the pressure sensors with different structures. (a)–(c) Diagrams and stress distributions of the different structures. (d) Average stress of the different patterned structures. (e) Simulated current variation curves. (f) Calculated surface areas of the microstructured electrodes. (g) Measured current variation curves.

dynamic process of the pyramids falling into the pores between the fibers. In addition, the surface area is a key factor for that a larger surface area contributes to more contact points between the conducting paper fibers and electrodes. The theoretical surface areas of the three structured electrodes (1 cm×1 cm) were calculated by the following formula:

<span id="page-5-1"></span>
$$
S_{A} = 1 + n(b^{2} - a^{2}) + 4na \frac{\sqrt{\left(\frac{a}{2}\right)^{2} + h^{2}}}{2} \left(1 - \frac{b^{2}}{a^{2}}\right),
$$
 (6)

where *n* is the number of pyramids, *a* is the length of the bottom side, *b* is the length of the topside, and *h* is the pyramid height. As shown in [Figure 2](#page-3-0)(b) and Figure S3, the top sides of the Pyramid, Frustum 1, and Frustum 2 are 0,  $\sim$ 30, and  $\sim$ 50 µm, respectively. From [eq. \(6\),](#page-5-1) the pyramid structure shows the highest surface area, enhanced by 34% compared to the electrode without any structure ([Figure 4](#page-5-0) (f)).

Figure  $5(a)$  presents the current variation curves of the pressure sensor under CNT concentrations varying from 0.5% to 2% under the external pressure of 10 kPa. The valve



<span id="page-6-0"></span>**[Figure 5](#page-6-0)** (Color online) Sensing performance of the pressure sensor. (a) Current variation curves of the pressure sensor under different MWCNT concentrations. (b) Surface of the conducting fiber paper with different CNT contents. (c) Current curves of the pressure sensor under different external pressures. (d) Fitted pressure sensitivity curve. (e) Current variation curve of the pressure sensor for 20,000 cycles. (f) SEM image of the micro-pyramid array structure after the cycle test.

of Δ*I*/*I* shows a growing tendency from 0.5% to 1.5%, ascribed to more MWCNTs attaching to the surface of the paper fibers and tends to decrease as the MWCNT concentration increases. This is because the MWCNT content on paper fibers reached the saturation point at the concentrate of 1.5%. Although the continuous increase in the MWCNT content improves the conductivity of PCM film (reflected by the decreasing surface resistance shown in Figure  $5(b)$ ), paper fibers with small gaps can contact each other through the MWCNTs (inset of Figure  $5(a)$ ), resulting in a smaller variation of conducting paths under the same external pressure, thereby affecting the current variation. As  $Figure 5(c)$  $Figure 5(c)$ illustrates, the pressure sensor exhibits high resistance variation when the pressure is altered widely from 0.98 to 19.8 kPa. [Figure 5](#page-6-0)(d) shows the Δ*I*/*I–*Δ*P* curves of the pressure sensor constructed with the micro-pyramid array electrode. After piecewise linear fitting, two curve segments based on the slope are observed. In the pressure range of 0–2 kPa, the pressure sensor displays an ultra-high sensitivity of 17.65  $kPa^{-1}$  due to the superimposed effect of increasing contact area originated from the 3D patterned structure falling into fiber paper, and a sensitivity of 2.06 kPa<sup> $-1$ </sup> in the pressure range of 2–150 kPa, superior to most of the previously reported paper-based sensors, listed in [Table 1.](#page-7-0) To investigate the performance stability, the current variation of the device is measured by a homemade motor system (Figure S4) under a repeated 1 N load/unload force for more than 20,000 cycles. The initial and final waveforms of the current response showed almost the same results, as shown in [Figure 5](#page-6-0)(e), revealing that the pressure sensor exhibits high repeatability, stability, and durability. The SEM image of the micro-pyramid array electrode after the cycle test is presented in [Figure 5\(](#page-6-0)f), wherein the micro-patterns and the sharp peaks remain intact after long-term compression, demonstrating favorable mechanical stability. Simultaneously, a response time of 75 ms was obtained, as shown in Figure S5.

In view of the excellent sensitivity of the as-fabricated sensor at a low-pressure stage, we applied the sensor to practical physiological signal detection. [Figure 6\(](#page-7-1)a) shows

<span id="page-7-0"></span>





<span id="page-7-1"></span>**[Figure 6](#page-7-1)** (Color online) Tactile signal detection applications of the pressure sensor. (a) Record of the pulse wave. (b) Amplified pulse waveform of (a). (c) Current variation of the pressure sensor under the repeat stimulation of an M4 nut. (d) Current variation of the pressure sensor attached on a finger at different bending degrees. (e), (f) Waveforms generated when saying different words. (g) Picture of a sensor array. (h) Pressure distribution when writing the letter "N" on the sensor.

the wrist pulse signals of a healthy human wearing the highsensitivity pressure sensor. According to the schematic, it is easy to accurately count the pulse (78 beats/min). [Figure 6\(](#page-7-1)b) presents a single pulse consisting of three wave peaks: the first systolic peak pressure  $(P_1)$ , the second systolic peak pressure  $(P_2)$ , and the diastolic wave  $(P_3)$  [\[55\]](#page-9-33), related to human health status. Through qualitative analysis of the pulse wave, some key parameters can be derived to evaluate health conditions, such as the radical Augmentation Index (AI), which is regarded as an index for evaluating vascular aging [\[56\].](#page-9-34) [Figure 6](#page-7-1)(c) shows that the pressure sensor can steadily and sensitively detect the pressure of a Teflon nut weighing about 50 mg (18 Pa). The pressure sensor can also fit the finger and measure its curvature, as shown in [Figure 6](#page-7-1) (d). Besides, the voice variation signals can also be detected. Figure  $6(e)$ –(f) respectively show the current variation curves when repeatedly saying "pressure sensor" and "carbon", revealing that different voice signals are significantly translated into corresponding current signals by the piezoresistive sensor. To expand the application of the sensor in large-area pressure detection, a pressure sensor array is fabricated based on the single flexible pressure sensor, as shown in Figure  $6(g)$ . The pressure sensor array contains  $3\times3$ pixels and a 5 cm $\times$ 5 cm testing area. As shown in [Figure 6\(](#page-7-1)h), the pressure sensor array can output distinguishable current variation signals reflecting the pressure distribution when writing the letter "N" on it with different forces, thereby showing favorable potential in the field of E-skin.

## **4 Conclusions**

In summary, a piezoresistive sensor with ultra-high sensitivity and a wide measurement range based on porous fiber paper and 3D patterned electrodes has been proposed. By optimizing the initial resistance of the conducting paper and the shape of the 3D pattern, the pressure sensor exhibits an ultra-high sensitivity of 17.65 kPa<sup>-1</sup> in the external pressure range of 0 to 2 kPa and retains a sensitivity of 2.06 kPa<sup> $^{-1}$ </sup> in a measuring range of 150 kPa. The enhanced performance is mainly ascribed to the couple effect of 3D patterned electrodes and porous sensitive layer. On the one hand, the 3D pyramid structure effectively enhances the surface area of electrodes, equivalent to the sensing nodes. On the other hand, the inverted pyramid can easily fall into the interior of the fiber paper through the pores, significantly facilitating the formation of numerous conducting paths and improving the current response. Additionally, the pressure sensor exhibits remarkable mechanical stability with a stable current response after 20,000 cycling tests. Based on the improved sensing performances, the pressure sensor achieves undistorted signal detection, including weak pulse, voice, and joint movements while attached to the human skin. This

work presents a novel strategy for significantly improving the sensitivity and measurement range of flexible piezoresistive sensors and demonstrates the applications with favorable prospects in intelligent healthcare.

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#### **Supporting Information**

The supporting information is available online at [tech.scichina.com](http://tech.scichina.com) and [link.springer.com.](https://springerlink.bibliotecabuap.elogim.com) The supporting materials are published as submitted, without typesetting or editing. The responsibility for scientific accuracy and content remains entirely with the authors.

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